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Applicant: Pavel, et al.
Title: METHOD AND APPARATUS FOR
PERFORMING HYDROGEN OPTICAL EMISSION
ENDPOINT DETECTION FOR PHOTORESIST
STRIP AND RESIDUE REMOVAL
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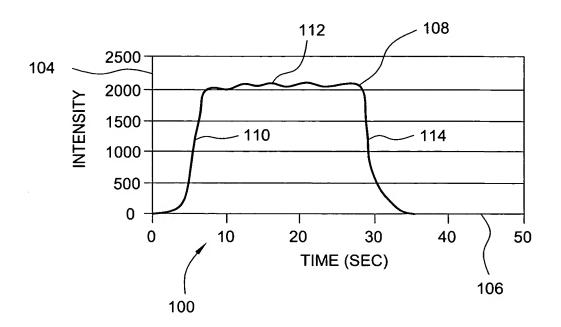


FIG. 1A

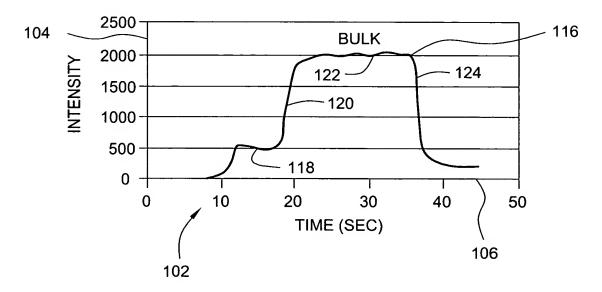


FIG. 1B

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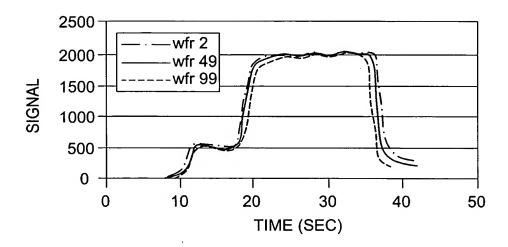


FIG. 2

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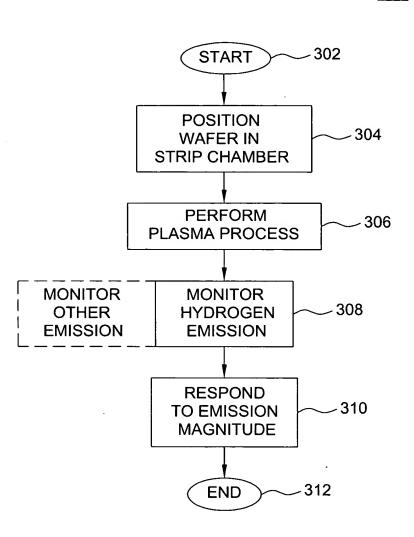
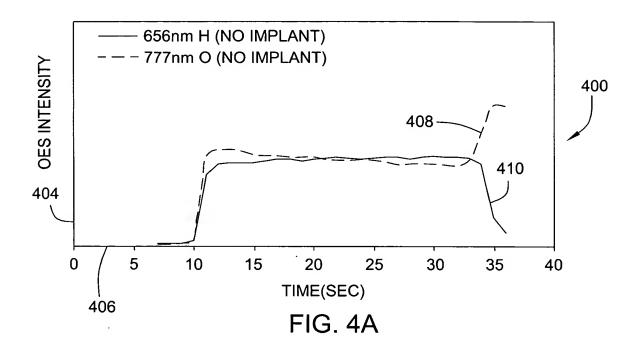
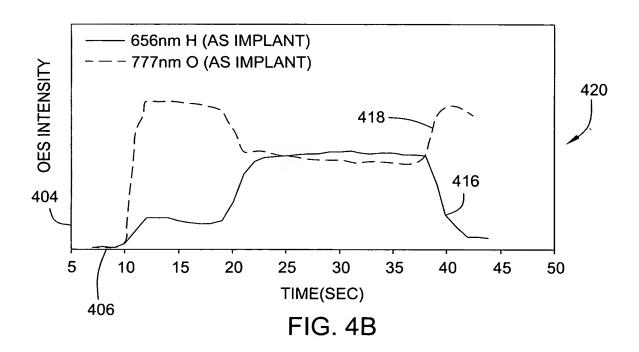


FIG. 3

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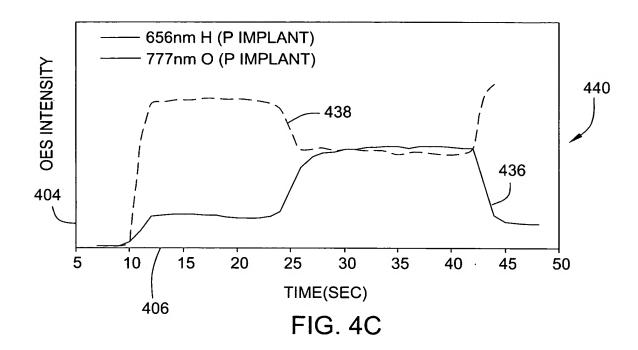


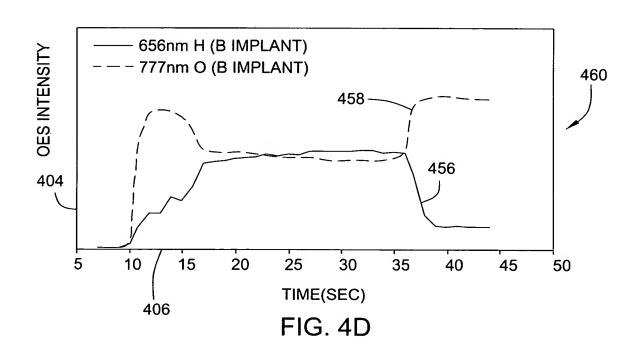


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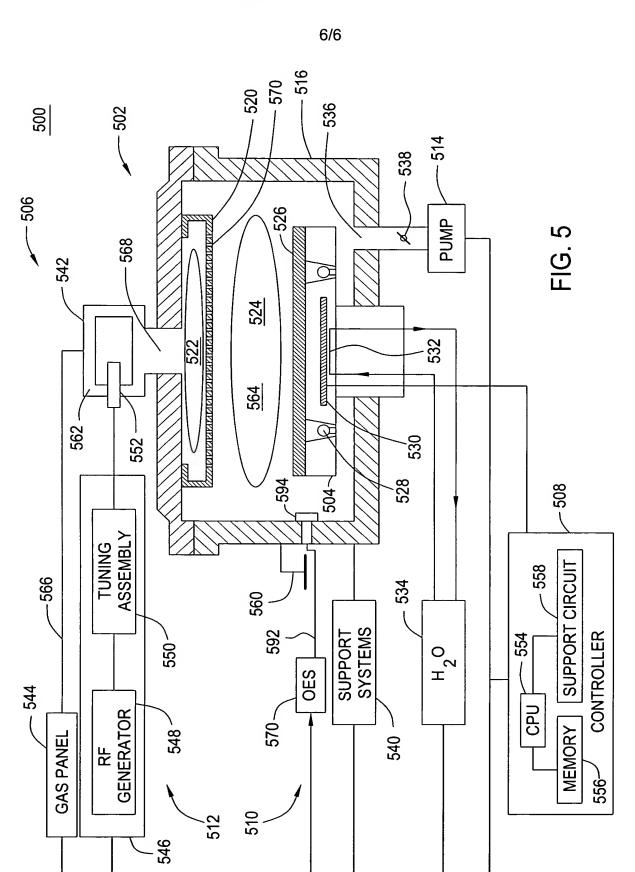
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